



MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2823

PATENT
0763-0150P

RECEIVED
AUG 21 2003
TO 2800 MAIL ROOM

IN THE U.S. PATENT AND TRADEMARK OFFICE

| | | | |
|------------|--|-----------|---------------|
| Applicant: | LEE, Jun S. | Conf.: | 5244 |
| Appl. No.: | 09/722,583 | Group: | 2823 |
| Filed: | November 28, 2000 | Examiner: | Kebede, Brook |
| For: | METHOD FOR FABRICATING CAPACITOR OF SEMICONDUCTOR DEVICE | | |

REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 18, 2003
(Monday)

Sir:

In reply to the Office Action dated April 17, 2003, the due date for response having been extended one (1) month to August 17, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims; and
Remarks.

08/19/2003 HVUONG1 00000066 09722583

01 FC:1251

110.00 DP